**PATENT** 

Case Docket No. H-951-03

In RE application of

I. SHIMIZU et al

Serial No.: 10/799,775

Group Art Unit:

2133

Filed: March 15, 2004

Examiner:

J. Kerveros

or: TEST SYSTEM AND MANUFACTURING OF SEMICONDUCTOR DEVICE

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

Transmitted herewith is an Amendment in the above-identified application.

Small entity status of this application under 37 CFR 1.9 and 1.27 has been established by a verified statement previously submitted.

A verified statement to establish small entity status under 37 CFR 1.9 and 1.27 is enclosed.

No additional fee is required.

The fee has been calculated as shown below:

(COL. 1)				(C	(COL. 2)		(COL. 3)	
	Re	Claims emaining After nendment		Hiç Pre P	Highest No. Previously Paid For		Present Extra	
Total	•	16	Minus		20	=	0	
Indep.	•	3	Minus	•••	3	=	0	
	et Proce	estation of N	Austinia Da		Claire			


SMALL ENTITY

OR

OR

Additional Fee Rate 9 42 \$ 140 Total

OTHER THAN A SMALL ENTITY

Rate	Additional Fee	
× 18	\$	0
× 84	\$	0
+ 280	\$	0
Total	\$	0

Col. 1 is less than the entry in Col. 2, write '0' in Col. 3.

If the 'Highest Number Previously Paid For' IN THIS SPACE is less than 20, write '20' in this space.

If the 'Highest Number Previously Paid For' IN THIS SPACE is less than 3, write '3' in this space.

The 'Highest Number Previously Paid For' (Total or Independent) is the highest number found from the equivalent box in

Col. 1 of a prior Amendment or the number of claims originally filed.

	Please	Please charge my Deposit Account No. 50-1417 in the amount of \$					
	A che	ck in the amount of \$ is attached in payment of:					
х	The Co	ommissioner is hereby authorized to charge payment of the following fees associated with this communication dit any overpayment to Deposit Account No. 50-1417.					
	x	Any filing fees under 37 CFR 1.16 for the presentation of extra claims.					
	x	Any patent application processing fees under 37 CFR 1.17.					
	X	Any Extension of Time fees that are necessary, which are hereby requested if necessary.					

MATTINGLY, STANGER & MALUR, P.C. 1800 Diagonal Rd., Suite 370 Alexandria, Virginia 22314 (703) 684-1120

Date: April 14, 2004

Daniel J. Stanger Registration No.

32,846 Attorney for Applicant(s)

H-951-03

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

I. SHIMIZU et al

Serial No. 10/799,775 Group Art Unit: 2133

Filed: March 15, 2004 Examiner: J. Kerveros

For: TEST SYSTEM AND MANUFACTURING OF SEMICONDUCTOR DEVICE

## PRELIMINARY AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

April 14, 2004

Sir:

Prior to examination, please amend the above application as follows.